4.0 INSTALLATION

Place the Hummer console on a table or counter-top which provides ample working area, approximately 10 square feet, near an electrical outlet. Set the glass vacuum chamber in the groove provided in the baseplate, and set the top plate in position on the chamber top. (Figure I) Insure that the contact areas of the chamber and gaskets are free from dirt or dust or other contamination. When needed, chamber rim and gaskets can be wiped clean and regreased with a very light film of silicone vacuum grease.

4.1 Checking Oil Level and Gas Inlet

All units except the Hummer Jr. are equipped with a vacuum pump which must be filled with oil prior to placing the unit in operation, 1 1/4 quarts of supplied mechanical vacuum pump oil is required. Oil is to be added through the rear oval opening of the cabinet by means of the exhaust port, after removing the copper elbow marked oil filling port in Figure 2 and using the small funnel and hose included with the accessories. Several inches below the oval opening is a small oil view port. Oil should be added until the level is halfway up the oil view port. When this level is obtained, refit the elbow to the exhaust port. A gas inlet is provided for the introduction of pure gases such as argon or dry nitrogen for more uniform and oxygen free depositions. A regulated tank pressure of 5 - 15 psi must be applied at the gas inlet. However, if deposition conditions are not critical for the sample. then the air inlet should be left free for the introduction of laboratory air. Figure 2 also shows connections to accessories such as cold stage and DTM.

4.2 Hummer Jr. Vacuum Pump Connection

The Hummer Jr. requires an auxiliary vacuum pump, attached in the rear, with a pumping rate of at least 2 cfm and an ultimate pressure of 10 millitorr. If the vacuum pump requires current at a rate equal to or less than the amperage listed on the serial number plate of the Hummer, it can be connected directly to the receptacle on the rear of the console. If the pump is left with its switch in the on position, it can be fully controlled by the main power switch of the Hummer Jr. Pumps with amperage ratings higher than listed on the Hummer will require separate electrical service. Attach the intake port of the vacuum pump to the vacuum port at the rear of the Hummer Jr. console with a suitable vacuum hose. Plug the



4.1A FILLING AND CHECKING OIL LEVEL

All units, except the Hummer Jr., are equipped with a vacuum pump, which must be filled before operation of the unit. Oil is added by first removing the rear panel of the cabinet (six small screws), and removing the exhaust muffler from the pump. ULVAC pump required 270 M.L. of oil.

Oil level should always be in the middle c.' the sight glass on all units.

4.1B GAS INPUT

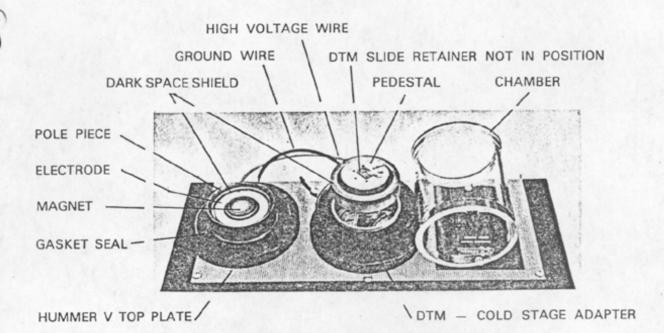
A gas inlet is provided at the right rear of cabinet for the introduction of pure gases such as argon or dry nitrogen for more uniform and oxygen free depositions. Reactive gases would also be introduced here. A regulated tank pressure of 5-15psi should be applied at the inlet. However, if deposition conditions are not critical, the gas inlet may be left free for the introduction of laboratory air.

4.1C VENTING OF CHAMBER

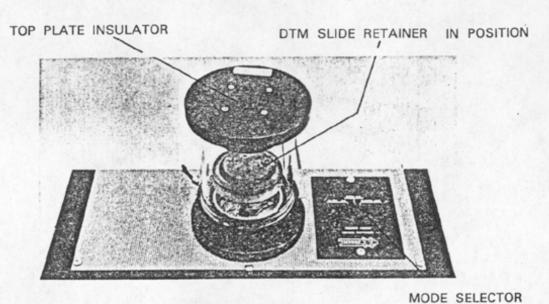
Venting is accomplished through the rear gas inlet, using the gas attached or laboratory air. If the chamber does not vent, check gas supply pressure. Venting usually occurs in ten to twenty seconds, depending on inlet pressure.

7.1 REMOVAL OF TARGET ELECTRODE

The electrode is mounted on three miniature banana plugs for easy removal. To remove the electrode, insert extractor between target electrode and dark space shield and pull gently, move extractor around circumference and pull several times until electrode is loose.



DISASSEMBLED



ASSEMBLED

FIGURE 1. HUMMER V

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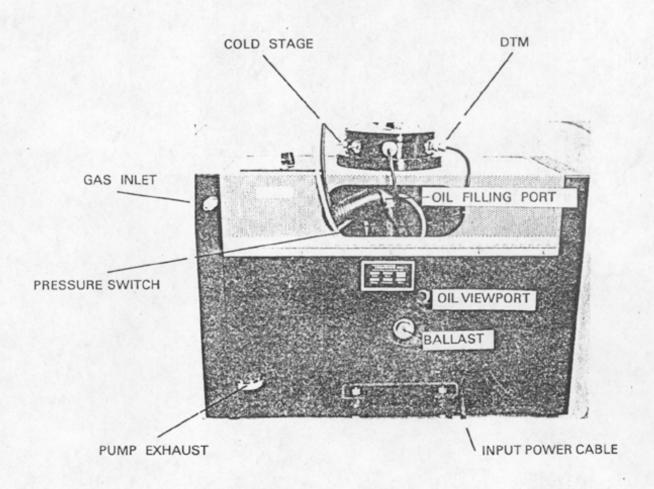


FIGURE 2. REAR VIEW

power cord of your Hummer unit to an electrical supply of 110-115 V AC, 15 amps, 60 hz or 220-230 V, 7 1/2 amps, 50 hz, as specified on the serial number plate.

Before placing your Hummer instrument into operation, familiarize yourself with the instrumentation and controls detailed in the following sections.

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5.0 CONTROLS - DESCRIPTION AND EXPLANATIONS (Figures 2, 3 and 4)

Vent Valve - used to vent the chamber to atmospheric pressure, allowing removal or replacement of specimens within the chamber. Leave the vent valve open when the pump is not in operation.

Gas Valve - used to introduce air or inert gases into the vacuum chamber and to regulate the pressure within the chamber. Vent valve must be closed in order for this valve to function. Only light two finger pressure is required to close this valve. Excessive force will damage this valve.

Main Power Switch - used to turn on the vacuum pump, vacuum gauge, and power supply. The amber light indicates that power is on.

Hi-voltage Switch - used to turn on hi-voltage supply which generates plasma. A red light indicates readiness.

Hi-voltage Control - used to adjust the amount of hi-voltage required.

Auto-manual Switch - used to select either manual operation or automatically timed operation. Note: High voltage light will not come on if switch is in automatic position and timer is set at zero.

Mode Switch Plate-Etch-Plasma - used to select mode of operation fir either D.C. plating, D.C. cleaning or etching, or plasma processing. The Hummer I, for plating only does not have a mode switch.

Test Switch - Hummer Jr. only) vacuum sensor to determine sufficient vacuum in the chamber to begin operation; indicated by a deflection of 5 milliamps or less on the milliamp meter when the test switch is activated.

Pulse Switch - (All Hummers except Hummer Jr.) used for intermittent pulsing of the plasma to provide smallest coating crystal nucleation and lowest rise of the specimen temperature. After turning on the pulse mode, it takes 30 seconds for warm up after which an on-off interval of 5 seconds will continue. Pulse can be selected in either automatic or manual mode.

Vacuum Pump Gas Ballast Valve - the gas ballast valve is operated by means of a knurled knob at the rear of the cabinet. Its use is to purge the vacuum pump oil of water and other volatile contamination. Normally, this valve is fully closed, (turned clockwise to stop), approximately I time per month turn the knurled knob 3/4 turn counter clockwise and run the vacuum pump under vacuum approximately I hour to vent all volatile contaminants. Regithten valve to original position. (See included manual for additional information on the vacuum pump.)



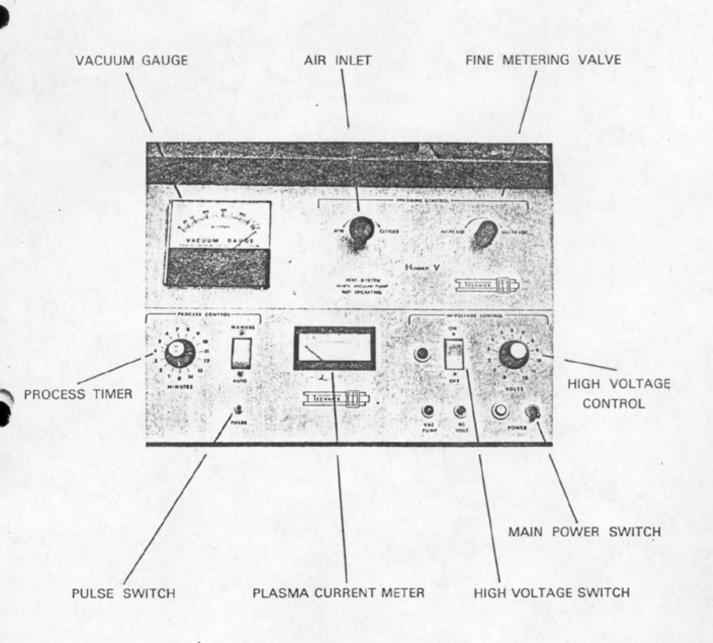


FIGURE 4. CONTROL PANELS



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Target Selector - (Hummer III only) depress target selector on the top of the Rotary Electrode Selector and rotate target selector know to select target 1, 2, 3, or E (etch) Electrode desired.

Pressure Switch - used as a safety device to cut off high voltage whenever chamber is at atmosphere.



6.0 OPERATION - HUMMER JR, I, II, III

6.1 First Pump Down

Check that all switches are off, and all valves closed before commencing operation with your Hummer. To place the Hummer in operation, first set all controls as follows:

Main Power Switch OFF
High Voltage Switch OFF
Voltage Control O
Process Control MANUAL
Vent Valve CLOSED
Pressure Control DECREASE
Mode Selector D.C. PLATE

Open chamber by lifting top plate or glass cylinder and place specimens on pedestal. Pedestal height should be adjusted to place specimen approximately 3/4 - 2" from top plate electrode. Loosen pedestal height adjust knob (Figure 3) (black plastic nut at base of pedestal. rod). Raise or lower pedestal as required. Retighten nut with thumb and forefinger only. Install desired electrode (electrodes in Hummer III) in top plate by turning clockwise until tight (Hummer Jr, I, II, and III). On the Hummer V, the ring-shaped electrode is held in place by three screws exposed by removing the black top plate insulator (Figure 1) from top plate. These screws are sealed by o-rings, and should be loosened or tightened evenly and with care when changing electrodes. Hummer II and V top plates are shown with and without electrodes in place in Figures 6 and 7. After installing the desired electrode, place top plate on the chamber and turn on the main power switch. Initial pump-down should take 15 to 20 minutes; thereafter, 2 to 5 minutes should be sufficient. Pump-down is complete when a vacuum reading of 20 millitorr or less is obtained. On the Hummer Jr., a test deflection of 5 milliamps indicates sufficient vacuum to continue to the next step.

For best operation, especially with carbon electrodes, an inert gas, such as argon should be attached via vacuum hose to the hose connector at the rear of cabinet, and regulated to a pressure of 5 - 15 psi, Figure 2.



6.2 Hummer V

The design of a Plasma Magnetron system was developed to eliminate effects of high temperatures during plating operations. A high magnetic flux crosses the flow of electrons accelerated toward the anode sample electrode (Pedestal). The electrons are, therefore, retarded and diverted toward a biased dark space shield. The result is a cool pedestal and sample.

6.3 Plate - General Operating Conditions

To plate specimens, place mode switch to plate position, turn hi-voltage switch to ON and turn hi-voltage knob to II. Open gas valve until vacuum reading is 80-100 millitorr. It should be noted that the initial appearance of the plasma will cause the pressure in the chamber to rise and fall due to molecular adhesion of water vapor and atmospheric gases. Adjustment of the gas valve is necessary to compensate for these fluctuations until the pressure stabilizes. Plasma will appear with a purple-blue glow. Vary pressure in chamber with the fine metering valve to achieve reading of 5-15 milliamperes. Set timer to desired number of minutes and turn switch to auto setting. Plasma will terminate automatically after the number of minutes selected have expired. If pulse mode is selected, timer totalizes only the ON cycle. When specimen has been coated to desired thickness, reduce hi-voltage control to zero, turn off hi-voltage switch, close gas valve, and turn main power switch off. Open vent valve, lift chamber top and remove specimen from chamber.

Typical operating conditions for Hummer I, II, III, and Jr.:

Gold or Gold/Palladium Deposition

Pressure 40-80 Millitorr (Argon)
Current 10 Milliamperes
Voltage Control Position 9 or 11
Plate Time 2 minutes

Carbon Deposition (Except Hummer Jr.)

Pressure 40-80 Millitorr (Argon)
Current 10 Milliamperes
Voltage Control Position 11 or 12
Plate Time 10 minutes



Typical for Hummer V:

Gold or Gold/Palladium Deposition

Pressure
Current
Voltage Control
Plate Time

30-50 Millitorr (Argon) 5-10 Milliamperes Position 9 or 11 1 minute

Carbon Deposition

Pressure Current Voltage Control Plate Time 20-40 Millitorr (Argon) 5 Milliamperes Position II or |2

10 minutes

Curves are shown for each in Figures 8, 9 and 10.

6.4 Etch - Typical Operating Conditions

To clean or etch specimens, place mode selector switch to Etch or clean position, turn on hi-voltage and increase hi-voltage knob to position 6. Open fine metering valve until vacuum reading is 50-70 millitorr. After plasma appears, adjust current to 10 milliamperes or less by using this valve for biological or organic samples and from 10-30 for inorganic samples.

Typical operating conditions for etching or cleaning functions:

Metallurgical Specimen

Pressure Current Voltage Control Etch Time 50-100 Millitorr (Argon)
20 Milliamperes
Position 8 - 10
6 - 10 minutes



Biological Specimen

Pressure 50-80 Millitorrs (Argon)
Current 10 Milliamperes

Voltage Control Position 9
Etch Time 2 - 5 minutes

6.5 Plasma Processing

The Plasma Processing is utilized for ashing, cleaning and etching of metals, ceramics, glasses, organics and composites. This is a chemical-physical variation as opposed to the D. C. Etching (Sputter Etching) which is a physical reaction by ion bombardment. The specimens are reacted with active specie of oxygen, carbon tetrafluoride or other reactive gas. In addition, organic and inorganic coating can be deposited by Plasma chemical vapor deposition (CVD).

To Plasma Process, place the mode selector switch to Plasma Exc. on Hummers II, III and V and to A/C and clean on Hummer Jrs. Next, turn on Main Power Switch and evacuate the system to 20 millitorr, increase gas valve to read a pressure of I torr, place high voltage switch to on and increase voltage control to produce a current of 20 ma. on the current meter. Process for desired time with desired gas; oxygen for cleaning, ashing and etching of organics, carbon tetrafluoride* for etching of metals, ceramics and glasses, ethylene for deposition of ethylene coatings and argon or nitrogen for cross linking of organic surfaces such as TEM and SEM specimens to improve stability to electron beam exposure.

Typical Plasma conditions for several processes follow:

Ashing - Cleaning - Etching of Organic and Carbon

Pressure I torr (oxygen)
Current 20 Milliamperes
Voltage Control Position 6
Time 10 minutes

*Vent toxic fumes



2. Etching of Metals, Ceramics and Glasses

Pressure 500 Millitorr (CF₄)*
Current 20 Milliamperes

Voltage Control Position 4
Time 5 minutes

Deposition of Ethylene Polymers

Pressure 500 Millitorr (Ethylene)
Current 20 Milliamperes

10 minutes

Voltage Control Position 5
Time Position 5

4. Cross Linking of Organics (A or N2)

Time

Pressure 100 Millitorr
Current 10 Milliamperes
Voltage Control Position 6

*Vent exhaust from room



7.0 MAINTENANCE

Occasional cleaning is necessary as component parts become coated with material. Chambers should be cleaned with water and Bon-Ami cleanser. Pedestal and shields surrounding the pedestal and electrode can be removed and scrubbed with steel wool, or Scotchbrite R and then washed with detergent and water. Metallic electrodes can be cleaned with acetone or perchloroethylene. Carbon electrodes should be cleaned with steel wool or emery paper.

Seals should be kept coated with a very light film of silicone vacuum grease. Electrodes are actually consumed during coating process and will take on a matte appearance when worn, usually after 1000 to 1200 depositions. Disc type electrodes i.e., Hummer Jr., I, II, and II, are easily removed by unscrewing directly from beneath the top plate. Ring type electrodes i.e., Hummer V, are fastened by three screws exposed by first removing the circular black plastic insulator from the top plate (Figure I). All Hummers (except Hummer Jr.) are equipped with a pressure interlock to prevent the high voltage from operating unless the chamber is under vacuum. This interlock switch is suspended vertically beneath the base plate and can be seen through the oval opening at the cabinet rear (Figure 2). This switch is an important safety feature and has been adjusted so that the hi-voltage is off when the chamber is vented, and on when the chamber is evacuated. A small adjusting screw is provided for this adjustment. Backing the screw out will allow the hi-voltage to come on at a higher pressure and advancing the screw will have the opposite effect.

Occasionally after long periods of use, the packing around the vent valve may become worn and the valve will feel loose. This tightness can be restored by first loosening the jam nut on the valve body located just behind the panel, and then tightening the chrome compression nut located just in front of the panel. This valve should then be repositioned and held in place by retightening the jam nut against rear of the panel. Some machines are equipped with a lift type vent valve which is not adjustable and requires no attention. Vacuum pumps normally require no attention other than to check the oil, which should be maintained at a level midway in the sight glass, located at the rear of the cabinet (Figure 2). The oil should be drained and refilled when pressures below 30 mt cannot be achieved with a good quality mechanical vacuum pump oil, a drain cock for this purpose is provided at the front-left corner of the pump. The lower panel in Figure 5 should be removed first. Oil capacity is 1 1/4 quarts, overfilling should be avoided. Refill as described in Section 4.1.

The exterior of the instrument should be kept clean by wiping with a damp cloth and spray cleaner, such as "409" R or "Fantastic" R. Avoid excessive scrubbing of the front panels and controls.

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8.0 ACCESSORIES

8.1 Water Cooled Pedestal

A water cooled pedestal, fitted as standard on the Hummer Jr. (Figure 3) is available as an option (Figures 1 and 2) for all other Hummer Models. This pedestal is used to keep the specimens below ambient temperatures when the heat generated during sputtering is objectionable.

To install, simply remove the standard pedestal and rod assembly and replace with the special water cooled assembly complete with adapter collar, which is placed between the base-plate and glass chamber. Using 1/8" PVD hose, connect the hose connection to a water supply of approximately 1/10 gallon per minute flow rate. The return hose should be directed to an appropriate drain, and the system should be checked for proper flow. Do not restrict drain or excessive pressure could cause rupture of hoses. The Hummer Cold Stages are designated HCS 1, HCS 11, HCS 111, or HCS V for use with the Hummer 1, 11, 111, V respectively.

8.2 Rotary Electrode Selector

The Rotary Electrode Selector, RES (Figure 5) is fitted as standard on the Hummer III, and can be ordered as an option for the other models. Usually fitted with a hoist to help support its weight, the RES is used to supply a compliment of four different electrodes, which can be selected for use without venting the vacuum chamber or interrupting the vacuum pump operation. This is especially useful in saving time when several coatings are desired on the same specimen. Electrodes are selected by depressing the top "target selector lock" and indexing the target selector to the desired position, numbered I – 3 for plating electrodes, or "E" for etching electrode. Electrodes are removed and replaced by using the same procedure as with the standard top-plate.

The Hummer hoist shaft is attached to the rear of the cabinet with two bolts. The carriage which rides up and down is keyed in a slot and holds the glass chamber with a band clamp. Two clips are provided to hold the RES firmly to the chamber by clamping to the band.



To operate, raise the hoist to the top of the hoist shaft and swing to the rear. The hoist will remain suspended until its again raised, moved forward, and then lowered until the chamber rests on the base plate. During initial installation, the band clamp should be left loose until the chamber is evacuated, when the clamp and top plate clips can be positioned and tightened in place. On subsequent pump downs, make certain that the hoist does not prevent the chamber from seating fully on the base plate, causing leakage. The RES and Hoist are not available for the Hummer Jr. The hoist can be used with conventional top plates and is available as a separate accessory.

8.3 Digital Thickness Monitor (All Hummers except Hummer Jr.)

8.3.1 Installation and Operation

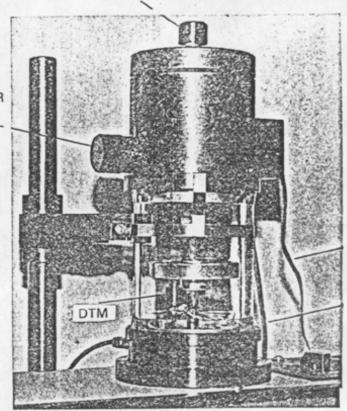
The Digital Thickness Monitor, DTM, is used to provide a means of measuring the thickness of coating, and reads directly in angstrom units. To install, remove the standard pedestal and rod assembly and replace with special DTM pedestal assembly complete with adaptor collar, which is placed on the base plate (Figure 5). The DTM panel replaces the blank panel at the lower front of the Hummer cabinet, and is connected to the rear of the power supply with the special four pin connector and cable provided. The coaxial cables are then passed through the opening at the bottom rear of the cabinet and connected to the adaptor collar, maintaining polarity by observing the color-coded connector.

To operate, place coverslip in the recess provided in the pedestal, and place the metal DTM slide retainer directly. over the coverslip. Turn on the DTM switch (Figure 5) and operate the Hummer in the regular manner, using argon gas and 10 ma current. The digital reading at this time is of no consequence because the photo cell resistance is reducing from its high dark current value toward its illuminated value of 10-20 K ohms. When sputtering begins, the DTM will begin counting backwards toward zero again for the reasons just explained, but will reverse and advance when the coating thickness and digital reading coincide. The values will continue to increase as the coating progresses, indicating the exact thickness of the coating on the control slide which is very nearly directly proportional to the thickness on the specimen being coated. The slide must be removed after each coating process. Always use a new



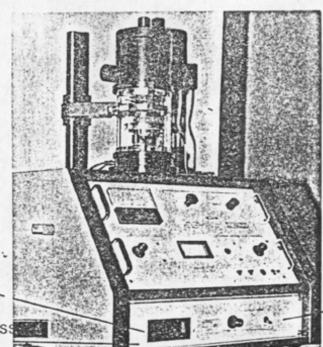
PRESS AND HOLD WHILE SELECTING TARGET

TARGET SELECTOR



GROUND LEAD

HIGH VOLTAGE LEAD



DIGITAL READOUT

OIL DRAIN VALVE

DTM CONTROL PANEL

FIGURE 5. ROTARY ELECTRODE SELECTOR



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coverslip for each run, and leave a coverslip in position even if the DTM is not being used.

8.3.2 Zero Calibration

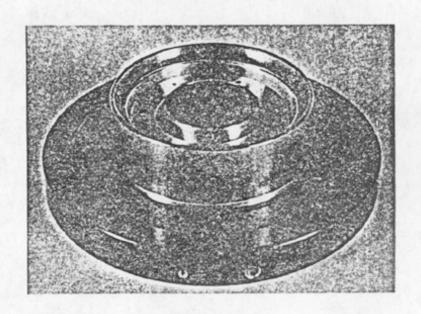
To check the zero calibration, position the zero adjust knob on the front panel to its central position. The potentiometer is a 10 turn pot. Position to one end and count back 5 turns.

Remove the slide and leave the retainer on the pedestal. Operate Hummer at voltage setting of 9 and 10 ma. The digital readout should read approximately -13. The reading can be adjusted within a few turns of the potentiometer and should be so adjusted. Replace slide and sample and operate.

The DTM is adjusted thoroughly before leaving the factory and should need no attention. Because this device is based on a photo-conductive principle of operation, extra bright or variable light conditions in the room can cause improper readings. Any further adjustment, if needed, should be carried out at the factory. The DTM is available on all Hummers except the Hummer Jr.

The DTM is also available in combination with the Cold Stage attachment.





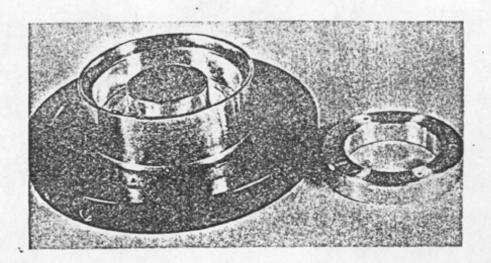
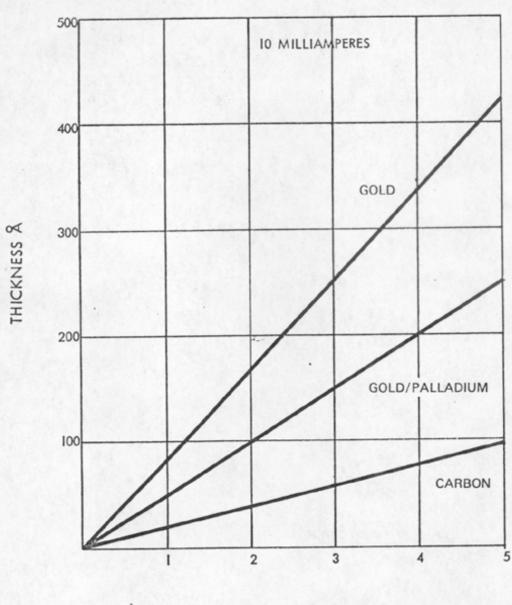


FIGURE 7. HUMMER V TOP ASSEMBLY



VOLTAGE CONTROL AT 12 ARGON AS SOURCE GAS



TIME - MINUTES

FIGURE 8. HUMMER V DEPOSITION CURVES



ECHNICS

9.0 REPLACEMENT PARTS AND ORDER NUMBERS

Parts can be ordered by giving a description of the part and quoting the serial number of the machine to which the spares are to be fitted. Below is a list of spares most normally utilized:

PART NO.		DESCRIPTION
20110-001 20110-002 20110-003 20110-004 20110-005 20110-006 20110-007 20110-008 20110-009 20110-010 21008-001		Gold Cathode-2" disc Hummer I, II, III, Jr. Copper Cathode-2" disc Hummer I, II, III, Jr. Nickel Cathode-2" disc Hummer I, II, III, Jr. Chromiun Cathode-2" disc Hummer I, II, III, Jr. Carbon Cathode-2" disc Hummer I, II, III, Jr. Aluminum-Etch Target-2" disc Hummer I, II, III, Platinum Cathode-2" disc Hummer I, II, III, Jr. Gold/Palladium-2" disc Hummer I, II, III, Jr. Palladium-2" disc Hummer I, II, III, Jr. Silver Cathode-2" disc Hummer I, II, III, Jr. Gold Gathode-3" ring Hummer V
21008-002 21008-003		Copper Cathode-3" ring Hummer V Nickel Cathode-3" ring Hummer V
21008-004 21008-005		Chromium Cathode-3" ring Hummer V Carbon Cathode-3" ring Hummer V
21008-006 21008-007		Aluminum-Etch Target-3" ring Hummer V Platinum Cathode-3" ring Hummer V
21008-008 21008-009		Gold/Palladium-3" ring Hummer V Palladium-3" ring Hummer V
21008-010 20215-20216		Silver Cathode-3" ring Hummer V Chamber Gasket Set-Hummer I, II, Jr.
10485		Chamber Gasket Set Hummer V
10486 20148		Rotary Electrode Selector Gasket Set T.C. Gauge Pickup
20214		Deposition Chamber
20217 20417	¥	Supertech Pump Oil, quart DTM Coverslips, 100



10.0 TROUBLE-SHOOTING GUIDE

A general guide to assist the operator in solving most simple failures

PROBLEM

No power when main switch is on

Power light comes on but pump will not run

Pump operates but no vacuum can be achieved

POSSIBLE CAUSE AND REMEDY

- Check that line cord is properly connected both at the power supply and at the wall receptacle.
- Check that circuit breakers are not thrown. Push button in to reset.
- Check that circuit breakers are not thrown. Push button in to reset.
- Check power connection between pump and rear of power supply.
- Check that remote switch on extreme right side of pump is in on position.
- Check to see that seals on top and bottom of chamber are free from dirt, dust, hair, etc.
- Make certain that pedestal adjustment nut is tight.
- Be sure both gas and vent valves are closed.
- Check all hoses and clamps for tightness including pump ballast valve and knurled lock-ring just below main pumping port hose.
- Be certain that proper volume of oil is in pump.

PROBLEM

System pumps down well but hi-voltage light will not come on

Hi-voltage is on but no plasma can be generated in any mode

Plasma can be generated in one mode, but in other modes, current meter is "pegged"

POSSIBLE CAUSE AND REMEDY

- Make certain that auto operation has not been selected with timer set to "zero".
- Check vacuum interlock switch for proper adjustment.
- Be sure that circuit breaker is not thrown. Push button in to reset.
- Check 6-pin hi-voltage connector at rear of power supply
- Check to see that pressure is in operating range.
- Check to see that hi-voltage lead from top plate is properly inserted in receptacle provided.
- Make sure that ceramic hi-voltage connector is attached to bottom of pedestal rod beneath base plate.
- Be certain that ground connection to top plate and to pedestal are properly made.
- Check to see that electrodes are properly positioned in top plate, especially with Hummer V units.
- Check 6-pin hi-voltage connector at rear of power supply
- Check all causes and remedies in previous section.
- Check to see that no foreign material
 is shorting electrode to the annular
 space shield surrounding the electrode.
 On Hummer V, see that no foreign
 material is attached to the magnet or
 pole piece.



PROBLEM

POSSIBLE CAUSE AND REMEDY

- Make sure that no foreign material is lodged between the pedestal and the surrounding annular space shield.
- Be sure that pedestal, electrode, and space shields are not excessively coated or dirty, especially when selecting etch mode.
- Plasma is present, but no coating can be achieved
- 1. Be sure voltage is in operating range
- Make certain that electrodes are serviceable by insuring that they are clean and free of surface contamination.
- Check to see that the inside of the glass chamber and all fixtures inside the vacuum chamber are clean, to prevent degassing and contamination of the coating.
- Purge chamber of contaminating gases by continually bleeding in and pumping out chamber with inert gas (argon).
 - Replace delay relay located at right rear inside of power supply.

Vacuum gauge will not work

Pulse mode will not work

- Check power connection between vacuum gauge and rear of power supply.
- Check connection between vacuum gauge tube.
- Replace gauge and tube as a matched set.

This section is only a guide to help solve the most commonly encountered problems. For unusual or difficult problems, do not hesitate to call on us for assistance. Direct your queries to the Service Department, where our qualified staff of service personnel are always anxious to help.

